

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/535,533	HADA ET AL.	
Examiner	Art Unit	
John S. Chu	1752	

	SEARCHED						
	SEARCHED						
Class	Subclass	Date	Examiner				
430	270.1	8/2007	JEC				
430	326	1	1.				
430	330						
430	905						
430	910	•	1				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
430	270.1	1/2007	JEC		
430	326,330		1		
430	905,910	L			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST UPDATED .	8/2007	Sec.		
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